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[illegible]

Form PTO-1449

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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ATTY. DOCKET NO.

2674-00003/US

APPLICATION NO.

10/776,192

APPLICANT

Torbjorn SANDSTROM

FILING DATE

2/12/04

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	Kind	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
W.C.	US 4 566 935		1986-01-28	Hornbeck	438	29	
	US 5 296 891		1994-03-22	Vogt et al.	355	67	
	US 5 504 504		1996-04-02	Markandey et al.	345	214	
	US 5 508 841		1996-04-16	Lin et al.	359	318	
	US 5 539 567		1996-07-23	Lin et al.	359	281	
	US 5 539 568		1996-07-23	Lin et al.	359	285	
	US 5 835 256		1998-11-10	Huibers	359	291	
	US 6 060 224		2000-05-09	Sweatt et al.	430	395	
	US 6 285 488		2001-09-04	Sanstrom	359	290	
	US 6 373 619		2002-04-16	Sandstrom	359	298	
	6 428 940		2002-08-06	Sandstrom	430	72	
✓	6 489 984		2002-12-03	Johnson	347	239	

FOREIGN PATENT DOCUMENTS

	Office	DOCUMENT NUMBER	Kind	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
								YES	NO
W.C.	WO 93	09469		1993-05-13	WIPO	—	—	X	
	EP	0 467 076		1992-01-22	EP	—	—	X	
	WO 99	45439		1999-09-10	WIPO	—	—	X	
	WO 00	42618		2000-07-20	WIPO	—	—	X	
	WO 98	04950		1998-02-05	WIPO	—	—	X	
	WO 99	22262		1999-05-06	WIPO	—	—	X	
✓	WO 99	45441		1999-09-10	WIPO	—	—	X	

OTHER DOCUMENTS

(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.

W.C.	H. KUCK et al., New System for fast submicron laser direct writing, SPIE Vol. 2440, pgs 506-514
W.C.	P.M. HAGELIN et al., Micromachining and microfabrication technology for adaptive optics, os 9/16/99
EXAMINER	DATE CONSIDERED
200	7/2/04

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